

<b>Notice of References Cited</b>	Application/Control No. 10/580,310	Applicant(s)/Patent Under Reexamination COLLOMB, CEDRICK STANISL	
	Examiner MAURICE MCDOWELL, JR	Art Unit 2628	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,704,024 A	12-1997	Voorhies et al.	395/125
*	B	US-5,864,639 A	01-1999	Chao, Philip C. J.	382/293
*	C	US-6,118,474 A	09-2000	Nayar, Shree K.	348/36
*	D	US-2003/0112238 A1	06-2003	Cerny et al.	345/426
*	E	US-2003/0171840 A1	09-2003	Haupt, Alexander	700/175
*	F	US-6,697,062 B1	02-2004	Cabral et al.	345/419
*	G	US-7,091,973 B1	08-2006	Cohen, Jonathan Michael	345/426
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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